

<b>Notice of References Cited</b>	Application/Control No. 10/652,253	Applicant(s)/Patent Under Reexamination HAFREN, JONAS	
	Examiner Dai A. Phuong	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0143991	07-2003	Minear et al.	455/419
*	B	US-2005/0108156	05-2005	Sumino et al.	705/040
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	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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